

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/234,233
Confirmation No. 6381
Filing Date January 20, 1999
Inventor Weimin Li et al.
Assignee Micron Technology, Inc.
Group Art Unit 2818
Examiner Dung Anh Le
Customer No. 021567
Attorney's Docket No. MI22-1035
Title: Semiconductor Processing Methods

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Reference -See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

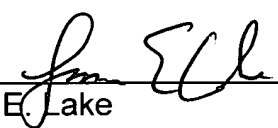
This Supplemental Information Disclosure Statement is being filed together with the filing of a Request for Continued Examination (RCE) Application. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

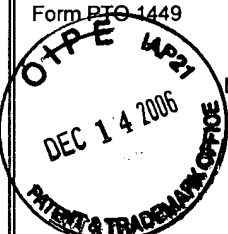
Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 14 Dec 2006

By: _____


James E. Lake
Reg. No. 44,854

Form PTO 1449 		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1035		SERIAL NO. 09/234,233	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Weimin Li et al.			
U.S. PATENT DOCUMENTS				FILING DATE January 20, 1999		GROUP 2818	
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,285,017	02/1994	Gardner			
	AB	5,789,819	08/1998	Gnade et al.			
	AC	6,156,485	12/2000	Tang et al.			
	AD	6,080,529	06/2000	Ye et al.			
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AJ						
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
	AP						
	AQ						
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							